



500.37328CX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): YOKOGAWA, et al
Serial No.: 09/336,687
Filed: June 21, 1999
For: PLASMA PROCESSING SYSTEM AND METHOD
Group: 1763
Examiner: L. Alejandro

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AMENDMENT

Mail Stop Fee-Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 19, 2003

Sir:

In response to the Office Action dated March 27, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Claims;

Remarks are included following the amendments; and

An Appendix including corrected Fig. 1 is attached following the

Remarks.